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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/902,502	07/09/2001	Kenneth A. Goldberg	LBL-CIB-1572 5914	
7590 03/11/2005		EXAMINER		
John P. O'Banion			LABAZE, EDWYN	
O'BANION & RITCHEY LLP			ART UNIT	PAPER NUMBER
Suite 1550 400 Capitol Mall		2876		
Sacramento, CA 95814			DATE MAILED: 03/11/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
Notice of Allowability	09/902,502 Examiner	GOLDBERG, KENNETH A. Art Unit				
, , , , , , , , , , , , , , , , , , , 	Examine					
·	EDWYN LABAZE	2876				
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.						
1. This communication is responsive to communication filed on 6/29/2004.						
2. The allowed claim(s) is/are <u>1-3,6-9,12-14,17-19,22-24,28-30,34,35 and 39</u> .						
3. The drawings filed on <u>09 July 2001</u> are accepted by the Examiner.						
4.						
Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/O Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ⊠ Interview Summary Paper No./Mail Da 98), 7. ⊠ Examiner's Amendr	te <u>2252005</u> .				

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SUPPLEMENTAL ACTION

EXAMINER'S AMENDMENT

1. Receipt is acknowledged of amendments filed on 6/29/2004.

2. Claims 1-3, 6-9, 12-14, 17-19, 22-24, 28-30, 34-35, and 39 are presented for

examination.

3. An examiner's amendment to the record appears below. Should the changes and/or

additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR

1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the

payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with

Mr. John O'Banion on 25 February 2005 (see the interview summary, paper no. 2252005).

4. The application has been amended as follows:

IN THE CLAIMS

5. Claim 30, line 16: Replace "claim 28" with -- claim 29--.

Claim 34, line 16: Replace "claim 31" with -- claim 29--.

Allowable Subject Matter

6. Claims 1-3, 6-9, 12-14, 17-19, 22-24, 28-30, 34-35, and 39 are allowed.

7. The following is an examiner's statement of reasons for allowance: The prior art of

record, Bokor et al. (U.S. 6,555,828) taken alone or in combination with any other references

fails to teach a means for simultaneously imaging multiple points in an area of a mask blank

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using reflections of light from an EUV light source, wherein the EUV detector is selected from a group of detectors consisting a CCD camera array and a micro-channel plate detector and a synchrotron. These limitations in conjunction with other limitations in the claimed invention were not shown by the prior art of record.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

8. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Johnson (U.S. 6,424,404) discloses multi-stage microlens array.

Baselmans et al. (U.S. 6,650,399) teaches lithographic projection apparatus, a grating module, a sensor module, a method of measuring wave front abbreviations.

Underwood et al. (U.S. 6,738,135) discloses system for inspecting EUV lithography masks.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to EDWYN LABAZE whose telephone number is (571) 272-2395. The examiner can normally be reached on 7:30 AM - 4:00 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael G. Lee can be reached on (571) 272-2398. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

el Edwyn Labaze Patent Examiner Art Unit 2876 February 25, 2005

> KARL D. FRECH PRIMARY EXAMINER